

FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEAttorney Docket No.:
GR 97 P 2734Applic. No.
09/161,196

Applicant

Frank Hintermaier

Filing Date
September 25, 1998Group Art Unit
2811

 INFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(37 CFR 1.98(b))

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
<i>ca</i>	J	196 49 684 C1	09/11/97	Germany			X
<i>ca</i>	K	0 726 600 A2	08/14/96	Europe			X
	L						
	M						
	N						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

<i>ca</i>	O	R. L. Ripley: "The Preparation And Properties Of Some Transition Phosphides", Journal of the Less-Common Metals, Vol.4, 1962, pp. 496-503;
<i>ca</i>	P	I.M. Watson et al.: "Chromium-phosphorus films deposited by the pyrolysis of an organometallic precursor", Thin Solid Films, Vol. 196, No. 1, February 1, 1991, pp. L21-L24

EXAMINER

ayg

DATE CONSIDERED

10-19-01

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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<i>an</i>	O	S. Motojima et al.: "Chemical vapour growth of HfP whiskers and their properties", Journal of materials Science, Vol. 31, 1996, pp. 5709-5715
<i>an</i>	P	T. Suren Lewkebandara et al.: "Precursor for the Low-Temperature Deposition of Titanium Phosphide Films", Chem. Mater., 1995, No. 7, pp. 1053-1054

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an

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